



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Masahiro NAKAYAMA, et al. : Confirmation Number: 6895
Application No.: 10/665,483 : Group Art Unit: 1772
Filed: September 22, 2003 : Examiner: Alexander S. Thomas

For: NITRIDE SEMICONDUCTOR WAFER AND METHOD OF PROCESSING NITRIDE SEMICONDUCTOR WAFER

LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the paper filed November 16, 2004 in this application, characterized by the Patent and Trademark Office as a Supplemental Response to Restriction Requirement With Traverse, be disregarded and removed from the file. In response to a telephone call on November 30, 2004 from Examiner Ackun, it was discovered that a clerical error occurred that resulted in the inadvertent filing of that paper in the wrong application. That paper is being filed separately with heading identification for the correct application file. The undersigned is grateful for the courtesy extended by Mr. Ackun.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Gene Z. Rubinson
Registration No. 33,351

600 13th Street, N.W.
Washington, DC 20005-3096
Phone: 202.756.8000 GZR:lnm
Facsimile: 202.756.8087
Date: December 2, 2004
WDC99 1011996-1.052775.0025

**Please recognize our Customer No. 20277
as our correspondence address.**